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(Not for submission under 37 CFR 1.99)

Application Number 10784903

Filing Date 2004-02-20

First Named Inventor Issaq et al.

Art Unit 2811

Examiner Name Nadav, Ori

Attorney Docket Number ACT-390

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	3	5126282	A	1992-06-30	Chiang et al.	
	4	5807786	A	1998-02-15	Chang	
	5	5965270	A	1999-10-12	Fang et al.	
	6	6107165	A	2000-08-22	Jain et al.	
	7	6124193	A	2000-09-26	Hawley et al.	
ON	8	6130572	A	2000-10-10	Ghilardelli et al.	

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ON	9	6259130	B1	2001-07-10	Wu	
	10	6316346	B1	2001-11-13	Gangopadhyay	
	11	6529038	B2	2003-03-04	Lambertson	
	12	6728126	B1	2004-04-27	Issaq et al.	
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	3	2005081976	WO	A3	2005-09-09	Actel Corporatoin		<input type="checkbox"/>
	4	1305454	GB	A	1973-01-31	Schunk & Ebe GMBH		<input type="checkbox"/>
	5	1461824	EP	A2	2004-09-29	Actel Corporation		<input type="checkbox"/>
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